

Notice of References Cited	Application/Control No. 10/020,034	Applicant(s)/Patent Under Reexamination MITROS ET AL.	
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	B	US-US006143594A	11-2000	Tsao et al.	
	C	US-US006188109B1	02-2001	Takahashi	
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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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